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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re the Application of: **Takuji TANAKA**

Group Art Unit: **2815**

Application Number: **10/604,891**

Examiner: **Eugene Lee**

Filed: **August 25, 2003**

Confirmation Number: **1890**

For: **SEMICONDUCTOR DEVICE AND METHOD OF  
MANUFACTURING THE SAME**

Attorney Docket Number: **031032**

Customer Number: **38834**

**AMENDMENT UNDER 37 C.F.R. §1.116**  
**EXPEDITED PROCESSING REQUESTED**

**MAIL STOP AF**

Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

July 13, 2006

Sir:

In response to the Office Action dated April 13, 2006, Applicants amend the claims as follows and submit the following remarks.

Amendments to the Claims begin on page 2 of this paper.

Remarks/Arguments begin on page 5 of this paper.